



Attorney's Docket No.: 09712-057001 / Z-202

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Peter de Groot et al.
Serial No. : 09/769,859
Filed : January 25, 2001
Title : OPTICAL SYSTEMS FOR MEASURING FORM AND GEOMETRIC DIMENSIONS OF PRECISION ENGINEERED PARTS

Art Unit : 2621
Examiner : Unknown

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Washington, D.C. 20231

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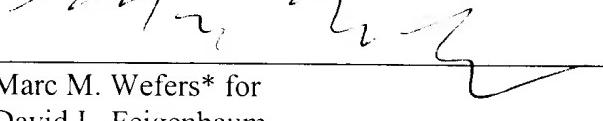
SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Copies of the references listed on the attached form PTO-1449 are enclosed.

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 4/8/03



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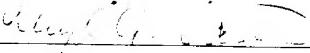
*See attached document certifying that Marc M. Wefers has limited recognition to practice before the U.S. Patent and Trademark Office under 37 C.F.R. § 10.9(b).

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I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.


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Substitute Form PTO-1449 (Modified) PATENT & TRADEMARK OFFICE		U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 09712-057001	Application No. 09/769,859
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Peter de Groot et al.		
		Filing Date January 25, 2001	Group Art Unit 2621	
(37 CFR §1.98(b))				

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	6,271,925	8/7/2001	Muller	356	512	
	AB	6,100,977	8/8/2000	Muller	356	354	
	AC	5,502,564	3/26/1996	Ledger	356	355	
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Foreign Patent Documents or Published Foreign Patent Applications							
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation
							Yes No
	AL						
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	AN						
	AO						
	AP						

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
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Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

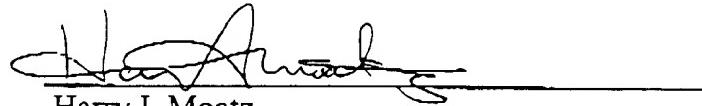
**BEFORE THE OFFICE OF ENROLLMENT AND DISCIPLINE
UNITED STATE PATENT AND TRADEMARK OFFICE**

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This document constitutes proof of such recognition. The original of this document is on file in the Office of Enrollment and Discipline of the U.S. Patent and Trademark Office.

Expires: December 23, 2003



Harry I. Moatz
Director of Enrollment and Discipline